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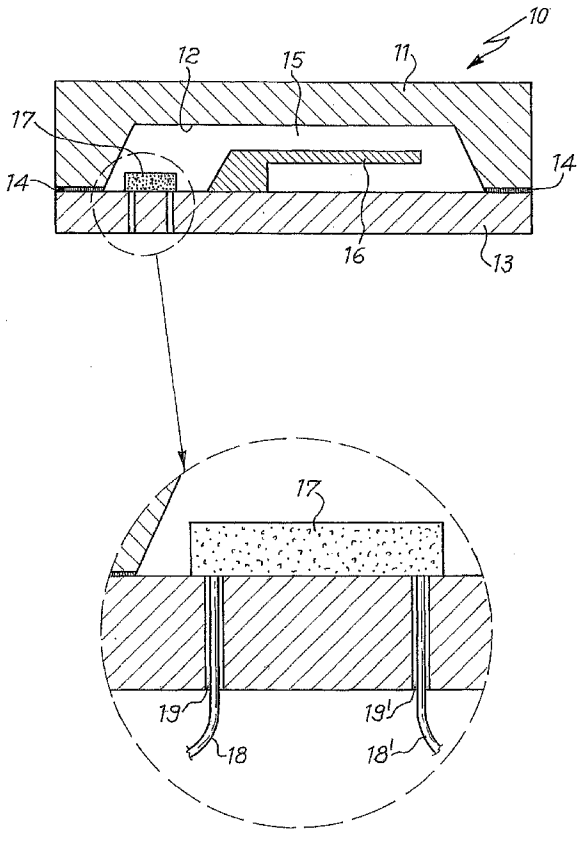
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(54) Title: MICROMECHANICAL OR MICROOPTOELECTRONIC DEVICES WITH DEPOSIT OF GETTER MATERIAL AND INTEGRATED HEATER, AND SUPPORT FOR THE PRODUCTION THEREOF




(57) Abstract: Micromechanical (10; 20) or microoptoelectronic (30) devices are described which comprises a deposit of getter material (17; 25; 35) for the sorption of gases being detrimental to the operation of said devices and an integrated system (18, 18', 19, 19') for heating the getter material from the outside at each moment this is required during the life of the device. Various embodiments of a support for manufacturing these devices are also described.

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